

Irradiation with Low Energy Heavy Ion at University of Wisconsin and PIE capability

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- 1.7 MV tandem accelerator from National Electrostatics Corporation (NEC)
- Temperature monitored with thermocouples and IR camera
- Various samples geometries
- Rastered or defocused beam
- Toroidal Volume Ion Source (TORVIS) and Source of Negative Ions via Cesium Sputtering (SNICS) ion sources



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HIGH-ENTROPY ALLOY (HEA) OVERVIEW

- Develop robust beam-intercepting devices (targets, beam windows, beam dumps, collimators...) to maximize physics benefits of future experiments
- Better assessment of current materials used in accelerators
- Develop novel materials to improve lifetime of components under extreme conditions → new materials specifically addressing the requirements of future target facilities.



(a) Conventional alloy, (b) High-entropy alloy (Miracle, Senkov | 2017)

HIGH-ENTROPY ALLOY (HEA) OVERVIEW

- High-entropy alloys (HEAs) are alloys with multiple principal elements
- Typically, no element >35 at%
- Usually defined as being primarily a solid-solution matrix
- Promising properties have been observed:
 - High-temperature strength
 - High specific strength
 - Enhanced radiation tolerance



Swelling of increasingly complex alloys under ion irradiation (Jin | 2016)

RADIATION DAMAGE IN METALS



RADIATION TOLERANT MICROSTRUCTURES

Typical approach to improving radiation tolerance: increase sink density



RADIATION TOLERANCE IN HEAS

Both modeling and experimentation have shown HEAs can exhibit enhanced radiation tolerance in the matrix



RADIATION TOLERANCE IN HEAS

Proposed mechanisms:

- Greater phonon scattering
- Sluggish diffusion of:
 - Atoms and point defects
 - Interstitial loops
- More trapping sites
- Broad migration energies
- And more!



WHICH HEA COMPOSITION TO USE FOR ACCELERATORS?

- Most commonly studied HEAs:
 - CoCrFeMnNi (Cantor alloy)
 - Al_xCoCrFeNi
 - Al_xCoCrCuFeNi
- Elemental selection considerations:
 - Primarily a single-phase alloy
 - Better ductility and manufacturability
 - Light-weight elements / low density
 - Reduced interaction with protons
 - Minimal activation under proton beam

Safer/easier to nandle after use



Most commonly used elements in HEAs from literature (Miracle | 2017)

WHICH HEA COMPOSITION TO USE FOR ACCELERATORS?

>1E+06

>1E+06



Predicted cooldown time for elements used in DEMO reactor divertor environment (Gilbert | 2019)

WHICH HEA COMPOSITION TO USE FOR ACCELERATORS?

- Most commonly studied HEAs:
 - CoCrFeMnNi (Cantor alloy)
 - Al_xCoCrFeNi
 - Al_xCoCrCuFeNi
- New HEA using Cr, Fe, Mn, Ti, V
 - Fe forms intermetallic compounds near the equimolar ratio with Cr, Ti, and V



Most commonly used elements in HEAs from literature (Miracle | 2017)

WHICH HEA COMPOSITION TO USE: CALPHAD



Takeaways:

Mn reduces the melting point substantially

V greatly promotes the formation of a single BCC phase

At lower temperatures, high Ti and Mn lead to the formation of many secondary phases

STARTING FROM LITERATURE



- Equimolar Cr-Mn-V shown to be single-phase BCC
- Ti additions reduce concentration of interstitial impurities by forming Ti-(C,O,N)
- Concerns Ti concentrations above ~8% will promote Laves phase formation
- 1200-°C, 100-hour heat treatment followed by water cooling to homogenize

 $CR_{33}MN_{33}V_{33}$

Cr₃₃Mn₃₃V₃₃

- Broad BCC phase field spanning ~1000 °C
- At 500 °C, the alloy is still >90% BCC





$CR_{31}MN_{31}V_{31}TI_{7}$

 $Cr_{31}Mn_{31}V_{31}Ti_7$

- Narrow BCC phase field spanning ~260 °C
- Laves phase (undesirable) predicted to form below 1160 °C







AL-CR-MN-TI-V HEA

$AI_{15}Cr_{20}Mn_{20}Ti_{10}V_{35}$

- Al shown to be a BCC stabilizer in multicomponent alloys + light weight
- Expands BCC stability range (ΔT) to 735 °C
- Increases melting point 75 °C







AL-CO-CR-MN-TI-V HEA

 $AI_{15}Co_{4}Cr_{15}Mn_{15}Ti_{6}V_{35}$

- 4% added Co at the cost of Ti promotes moderate B2 phase formation while maintaining sufficient Ti for impurity gettering
- Further substitution of Cr for Mn helps to mitigate solidus temperature depression from Co additions





V^{2+} Ion irradiation 50/100 dpa at 500C

• PIE is ongoing













IN COLLABORATION WITH PROF. DAN THOMA AT UW-MADISON

- Elemental powders are controlled independently
- Powders are delivered to print head by argon flow gas
- Laser down optic axis melts powders
- Focus on steels component FeCrMnNi for method validation







- 4 MeV Ni2+ ions
- High temperature: 500 °C
- 200 dpa at peak damage



Challenge: Irradiate 25 samples in a limited period of time



Development of the high-throughput irradiation stage and chamber



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 Necessity to shape the ion beam to irradiated only half of each sample → Comparison between irradiated and unirradiated areas



HEA additively printed plate in chamber



Ion beam positioning using electrostatic deflectors



Ion beam shaping (Ta apertures) and Automated Faraday cup insertion for current reading



 Need to perfectly align three beams (ion beam, IR laser, pyrometer) on the same spot → Camera inside the irradiation chamber



HEA additively printed plate in chamber



2kW laser turning off and still glowing red hot while the surrounding samples are cool



24 In-situ IR camera and pyrometer reading for temperature control





- IR laser (2kW) to heat the sample surface during irradiation (irradiation at temperature)
- Pyrometer to detect temperature in-situ and feedback loop to laser power
- Can reach 500C in 316SS in minutes with excellent temperature control

M. Moorehead, B. Queylat, H. Zhang, K. Kriewaldt, A. Couet, Development of a versatile, high-temperature, high-throughput ion irradiation system, Nucl. Instruments Methods Phys. Res. Sect. A 1020 (2021) 165892.



Number of samples	75	
lons	4 MeV Ni ²⁺	
Irradiation temperature	500 °C	
Vacuum	10 ⁻⁶ torrs	
Peak damage	200 dpa	
Damage rate	0.04 dpa.s ⁻¹	
Total irradiation time	100 hours	















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WISCONSIN-MADISON

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- TORVIS: High current H, D, and He ions, from < 1 µA to 100 µA. Large flat damage/depth profile
- SNICS: Wide range of heavy ions, Fe, Si, C, V, Nd, and more. Fast to achieve high damage, e.g., 250 dpa peak damage of stainless steels in less than 8 hours. No radiation-induced radioactivity.
- Rastered or defocused beam can be provided

Beamline	Irradiation damage	Surface analysis	High-throughput irradiation
Temp Range:	50°C-1000°C ±30°C	-150°C-1100°C ±5°C	RT to 800C (laser heating)
Temp. control	2 thermocouples + IR camera	3 thermocouples + IR camera	thermocouples + IR camera
Flux Range (cm ²)	5x10 ¹² - 2x10 ¹⁴	1x10 ¹⁰ – 2x10 ¹⁵	1x10 ¹⁰ – 2x10 ¹⁵
Irradiation Area	1.5 - 2.3 cm ²	0.1 - 6cm ²	0.1 - 225cm ²
Vacuum	1e-7 Torr	1e-8 Torr	5e-7 Torr
In-situ analysis	Resistivity measurement	RBS,NRA,PIXE	3D movement and rotation, and variable heating
Sample size	1cm x 2cm	1cm x 1.5 cm	15cm x 15 cm

STRETCH GOAL: ADD SEMI-COHERENT PRECIPITATES

- Ordered BCC phase (B2) expected to be semi-coherent with BCC lattice
- No Mn-containing (or concentrated) CrMnTiV alloys exhibit a B2 phase at low temperatures
- Dilute Ni or Co additions to Al₁₅Cr₂₀Mn₂₀Ti₁₀V₃₅ promote B2 formation



NuMat2020 | Online

Irradiation induced hardening

- For each samples: 3 line-scans (10 indents each) have been done across the interface
- Total time: 44 hours per plate (3mn/indent)





UW – IBL: EXAMPLE 2 – HIGH THROUGHPUT IRRADIATION OF HEAS Irradiation induced void swelling measured by profilometry:

- Profilometry is a relevant semi-high throughput technique to measure irradiation induced void swelling.
- Under development for highthroughput capabilities







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UW – IBL: EXAMPLE 3 – IN-SITU IRRADIATION IN MOLTEN SALTS (2022)





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- For sample preparation of low-active materials
 - Parallel polisher
 - Low speed saw
 - Electro-polisher
 - Ion mill
 - High accuracy balance







• JEOL 6610 SEM with Energy Dispersive Spectroscopy (EDS) and Electron Backscatter Diffraction (EBSD) capabilities in rad area:



• For sample characterization in non-rad area (after sample prep in rad-area)



FEI Helios G4 UX Plasma FIB/FE SEM



FEI Titan Cs-corrected scanning transmission electron microscope



Hysitron TI 950 TriboIndenter